



PATENT  
Customer No. 22,852  
Attorney Docket No. 8071.0007-00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Takeshi MITSUISHI et al. ) Group Art Unit: 2872  
)  
Application No.: 09/986,907 ) Examiner: Joshua Pritchett  
)  
Filed: November 13, 2001 )  
)  
For: COMPOSITION FOR VAPOR ) Confirmation No.: 6647  
DEPOSITION, METHOD FOR )  
FORMING AN ANTIREFLECTION )  
FILM, AND OPTICAL ELEMENT )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicants hereby petition for a two-month extension of time to reply to the Office  
Action of April 8, 2004. A fee of \$420.00 is enclosed.

Please grant any extensions of time required to enter this response and charge  
any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

09/08/2004 SDENB0B1 00000106 09986907

02 FC:1252

420.00 0P

Dated: September 7, 2004

By: Charles E. Van Horn  
Charles E. Van Horn  
Reg. No. 40,266